EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	2	("4465368" | "5493403").PN.	US-PGPUB; USPAT	OR	ON	2010/12/17 10:08
L2	31	(detect$3 sens$3) near3 (immersion liquid fluid water) same (load$3 unload$3) near2 (wafer substrate workpiece) and ($5lithograph$2 exposure).ab.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/17 10:26
L3	7	(detect$3 sens$3) near3 (immersion liquid fluid water) with (table support chuck holder) same (load$3 unload$3) near2 (wafer substrate workpiece) with (table support chuck holder) and ($5lithograph$2 exposure).ab.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/17 10:26
L4	12	(detect$3 sens$3) near (immersion liquid fluid water) with (table support chuck holder) same3 (load$3 unload$3) near (wafer substrate workpiece) with (table support chuck holder) and ($5lithograph$2 exposure).ab.	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/17 10:26

L5	12	(detect$3 sens$3) near (immersion liquid fluid water) with (table support chuck holder) same3 (load$3 unload$3) near (wafer substrate workpiece) with (table support chuck holder)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/17 10:27
L6	12	(detect$3 sens$3 camera determin $5) near (immersion liquid fluid water) with (table support chuck holder) same3 (load$3 unload$3) near (wafer substrate workpiece) with (table support chuck holder)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/17 10:27
L7	3	(detect$3 sens$3 camera determin $5) near3 (residual remain$3 leftover undesir$4 unwanted stray leak$3) near (immersion liquid fluid water) with (table support chuck holder) same3 (load$3 unload$3) near (wafer substrate workpiece) with (table support chuck holder)	US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2010/12/17 10:27

| L8 | 5 | (detect$3 sens$3 camera determin $5) near3 (residual remain$3 leftover undesir$4 unwanted stray leak$3) near (immersion liquid fluid water) same10 (load$3 unload$3) near (wafer substrate workpiece) with (table support chuck holder) | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2010/12/17 10:27 |
| L9 | 3 | (detect$3 sens$3 camera determin $5) near3 (residual remain$3 leftover undesir$4 unwanted stray leak$3) near (immersion liquid fluid water) same10 (load$3 unload$3) near (wafer substrate workpiece) with (table support chuck holder) and ($5lithograph$2 exposure).ab. | US-PGPUB; USPAT; USOCR; FPRS; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2010/12/17 10:27 |

12/17/2010 10:34:21 AM
C:\ Documents and Settings\ mliu1\ My Documents\ EAST\ Workspaces\ 10587268 imm detection light liq shape.wsp